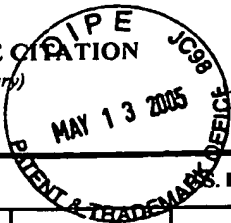


INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)



Docket Number (Optional)
NEC01P069-MSb

Application Number
09/851,313

Applicant(s)
Tatsuya Usami

Filing Date
May 9, 2001

Group Art Unit
2823

PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
RR		6,054,379	04/25/00	Yau et al.	438	623	02/11/1998
RR		6,812,131	11/02/04	Kennedy et al.	438	623	04/11/2000
RR		6,080,526	06/27/00	Yang et al.	430	294	02/24/1998
RR		6,197,703	03/06/01	You et al.	438	778	08/17/1998
RR		6,869,896	03/22/05	Cheung et al.	438	789	08/26/2003
RR		6,168,726	01/02/01	Li et al.	216	79	11/25/1998

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

Julio J. Maldonado

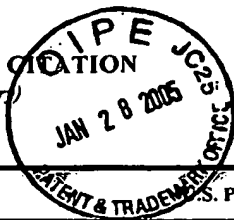
DATE CONSIDERED

07/07/1998

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Docket Number (Optional)

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Application Number

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Applicant(s)

Tatsuya Usami

Filing Date

05/09/01

Group Art Unit

2823

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>JP</i>		6,624,061 B2	09/23/03	Aoki	438	422	05/14/1999
<i>JP</i>		6,800,928 B1	10/05/04	Lee et al.	257	632	05/08/1998

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>JP</i>		Sun-Young Kim et al., HOSP as a Low Dielectric Material: Comparative Study Against Hydrogen Silsesquioxane, 1999 IEEE, 28-221
<i>JP</i>		

EXAMINER

Julius Maldonado

DATE CONSIDERED

05/07/2005

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INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				ATTY DOCKET NO. NEC01P069-MSb		SERIAL NO. 09/851,313			
				APPLICANT(S) Tatsuya Usami					
				FILING DATE May 9, 2001		GROUP 2823			
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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE			
<i>DR</i>	6,503,818	01/03	Jang, Syun-Ming	438	584	04/2/1999			
<i>DR</i>	6,265,780	07/01	Yew, et al.	257	759	12/01/1998			
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<i>DR</i>	6,326,692	12/01	Pangrle, et al.	257	758	02/23/2000			
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<i>DR</i>	6,403,471	06/02	Lou, Chine-Gie	438	687	09/04/2000			
FOREIGN PATENT DOCUMENTS									
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION		
								YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)									
EXAMINER <i>Julio J. Valenzuela</i>					DATE CONSIDERED <i>07/07/2001</i>				

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